

| Search Notes | Application/Control No. | Applicant(s)/Patent under Reexamination |
|--|-------------------------|---|
|  | 10/654,884 | KABUO, CHIE |
| | Examiner | Art Unit |
| | Naum B. Levin | 2825 |

| INTERFERENCE SEARCHED | | | |
|------------------------------|-----------------|-------------|-----------------|
| Class | Subclass | Date | Examiner |
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